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Rec. No.: EV 332277120 US

On: September 17, 2003

By: Millie A. Moran
MILLIE A. MORAN

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Toru TATSUMI, et al.

Serial No.: 09/744,701

Filed: January 29, 2001

Title: Method of Vapor Phase Growth of Metal Oxide Dielectric Film and Apparatus for Vapor Phase Growth of Metal Dielectric Material

Examiner: H. Jey Tsai

Group Art Unit: 2812

RECEIVED
SEP 25 2003
TECHNOLOGY CENTER 2800

September 17, 2003

Assistant Commissioner of Patents
Washington, DC 20231

PETITION FOR EXTENSION OF TIME

SIR:

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

- ☐ one month ☒ three months
☐ two months ☐ four months

The fee set in 37 CFR 1.17 for the extension of time is \$930.00.

- ☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.
- ☒ Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.
- ☐ Applicant is a small entity entitled to pay reduced fees in this application.

A verified small entity statement:


- ☐ has been filed ☐ is enclosed.

09/22/2003 ZJUHAR1 000000086 501290 930.00 DA
01 FC:1253

Also enclosed is a:

☐ Response ☐ Drawings ☐ Notice of Appeal ☐ Appeal Brief

Respectfully submitted,



Michael I. Markowitz
Reg. No. 30,659

CUSTOMER NUMBER 026304

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Docket No.: NECW 18.281
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